



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/589,962

Examiner: C. RIDDLE

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND
DEVICE MANUFACTURING METHOD

AMENDMENT WITH RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 14, 2009 Office Action and the October 27, 2009 personal interview, prosecution being reopened by the attached Request for Continued Examination, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.